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P/2107-277

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Christoph WAGNER et al.
Serial No.: 10/536,861
Filed: July 20, 2006

New York, New York
Date: September 22, 2006
Group Art Unit: 2655
Examiner: ---

For: METHOD AND DEVICE FOR OPTICAL FORM MEASUREMENT AND/OR
ESTIMATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2006

Robert C. Faber

Name of applicant, assignee or
Registered Representative

Signature

September 22, 2006

Date of Signature

Respectfully submitted,

Robert C. Faber

Registration No.: 24,322

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

RCF:mjb
Enclosures



APPLICANT'S ART CITATION (Use separate sheets if necessary)	Application 10/536,861	OFGS File No. P/2107-277
Applicant Christoph WAGNER et al.		
Filing Date July 20, 2005		Group Art Unit 2655

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-5,777,244	07-1998	Kumagai et al.	73	865.8	
	US-					
	US-					
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	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	WO 01/69214	09-2001	PCT				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Search Report dated August 31, 2006.

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.